

Electronic Patent Application Fee Transmittal

Application Number:	10536621			
Filing Date:	26-May-2005			
Title of Invention:	Polishing pad and method of producing semiconductor device			
First Named Inventor/Applicant Name:	Masahiko Nakamori			
Filer:	Karoline A. Delaney/Alanna Wai			
Attorney Docket Number:	UNIU40.005APC			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Statutory disclaimer	1814	1	130	130
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				130